

| Search Notes<br> | Application/Control No. | Applicant(s)/Patent under Reexamination |
|--|-------------------------|---|
|  | 10/784,772              | LEE ET AL.                              |
|  | Examiner                | Art Unit                                |
|  | Jeffrie R. Lund         | 1763                                    |

| INTERFERENCE SEARCHED |          |      |          |
|-----------------------|----------|------|----------|
| Class                 | Subclass | Date | Examiner |
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